Low-Temperature in Situ Large Strain Plasticity of Ceramic SiC Nanowires and Its Atomic-Scale Mechanism

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ABSTRACT

Large strain plasticity is phenomenologically defined as the ability of a material to exhibit an exceptionally large deformation rate during mechanical deformation. It is a property of some polycrystalline solids2 and has been well established for metals and alloys.3 With the reduction in dimensionality, nanomaterials exhibit unusual and unique behavior such as high hardness and high strength that have been demonstrated in nanowires of metals4 and ionic5 and covalent6 materials. For ceramic materials, it is naturally hard but very brittle. Large strain plasticity of bulk ceramic materials does not occur at low temperatures. Ceramics are brittle materials at room temperature and they usually break at small strains of 0.1—0.2% or even smaller.7 Bulk brittle materials can transform to ductile by creating dislocation and fostering dislocation motion at high temperatures, even as high as 2/3 of the melting point $T_m$ of the bulk8 or phase transformation at high pressure. Understanding the atomic mechanisms and dynamics of a brittle material impacted by an external force is fundamentally important to theoretical and applied physics, such as atomic lattice elastic-plastic response9,10 brittle—ductile (B—D) transition,11—13 materials toughness, hardness,14 and fractures.15 Recently, with the emergence of new directions in flexible dimensionality of electronic devices and forms16,17 as well as advancements in single nanowire (NW) electronics,18 it has become crucial to assess the nanoscale mechanical responses such as elastic—plastic deformation of the most important semiconductor materials, such as Si and SiC.

Experimentally, nanoindentation,19,20 atomic force microscopy (AFM),16 and in situ transmission electron microscopy (TEM)21,22 have been used to characterize the nanomechanical properties of nanodomains19,20 and single NWs.4,22 From the theoretical perspective, recent developments in simulation techniques have opened new approaches for investigating the microscopic origins of complex nanomaterial phenomena.10,19,23,24 However, contradictory results have emerged; for example, brittle-fracture features with small strain were
observed by large atomic number molecular dynamics (MD) simulations\textsuperscript{23,36} for SiC NWs. On a contrary scenario, large strain elasticity and ductile fracture features were achieved.\textsuperscript{25} Obviously, experimental evidence is necessary and mandatory to clarify the true deformation features and mechanisms of the ceramic nanowires. A full understanding about the atomic scale features of a NW under deformation remains a challenge due to the difficulty of simultaneous testing and nanoscale imaging. In particular, with respect to the elastic–plastic and B–D transitions, the physical picture regarding the atomic scale mechanisms and dynamics of an individual NW remains to be investigated.

In this Letter, we use the recently developed in situ TEM technique (see Supporting Information and Figure S1) to perform bending deformation of single SiC NWs. We present complete and dynamic atomic evolution images to reveal the very unusual mechanical behavior of a SiC NW under deformation. The observation may also help us to understand some of the intrinsic and/or universal mechanical behavior of nanoscale materials of semiconducting or ceramic characteristic. The in situ SiC NW elastic, elastic–plastic and plastic deformations were conducted in an ultrahigh resolution transmission electron microscope by bending SiC NWs via the mechanical force produced by the transmission electron microscope specimen-supporting grid under the irradiation of the electron beam\textsuperscript{26,27} (see Supporting Information). Figure 1 shows a series of images of a single SiC NW that was being deformed by the force created from the TEM grid under the irradiation/heating of an electron beam. A clear plastic deformation is observed at the bending region. Instead of a crystalline fracture, the NW has transformed from crystalline to amorphous at the mostly strained region. Among of 20 SiC NWs that had been studied, all of them had shown large elastic strain (up to 2%), and four of them revealed plastic deformation with the strain aggressively extended. Parts a and c of Figure 2 show an example of the starting elastic deformation of a SiC NW and parts b and d of Figure 2 display the final plastically deformed images of the single bent SiC NW, respectively. The series of images captured in situ in both the elastic and plastic deformation modes can be viewed in Figure 1. The strain rate was kept at a level of $10^{-4}$–$10^{-5}$/s. The up limit strain for inducing elastic deformation of SiC NW at relatively low temperature is around 2%, which is within the same order of magnitude as that reported for ex situ studies,\textsuperscript{28} and is consistent with theoretical predictions.\textsuperscript{29} For the in situ observed plastically bent SiC NW, until the diameter of the plastic necking zone decreased from 86 to 67 nm, a large plastic strain at the plastic necking valley has been achieved. We could not observe any cracks even at nanoscale or atomic scale. Accordingly, we can predict that the fracture strain of SiC NWs with a diameter of tens of nanometers could be as high as a few hundreds percent or even more, which reveals a large strain plasticity nature. To our knowledge, this is the first observation of large strain plasticity of SiC NWs at temperatures close to room temperature.

One of the key questions that one may ask is how high is the local temperature under the electron beam. Our experiment was carried out at 200 kV and with a low electron flux dose rate around $5 \times 10^{19}$ e/(cm$^2$ s). According to the model presented by Jencic et al. (ref S3), a simple calculation for such a dosage indicates that the local temperature is no more than a few degrees above room temperature. More importantly, during the entire experiments, the electron beam was spread to illuminate an area that is as large as 10–20 μm and we avoided the full convergence of the beam to a
small area to eliminate radiation damage. Therefore, the
temperature effect and irradiation damage introduced by the
electron beam were negligible.

The starting amorphous regions possess typical bending-
induced tensile-compressive features with up-tensile, bottom
compressive, and center-neutral stress areas. As shown in
parts e and f of Figure 2, an astonishing phenomenon is that
a butterfly shaped tensile-compressive amorphous zone is
clearly visible and reveals the asymmetric features of the
tensile-compressive strain field. The top and bottom regions
are the highest level strain regions and therefore are the first
to trigger plastic deformation. The plastic deformation is well
visualized by the formation of an amorphous phase with
distinctive contrast compared to the crystalline regions.30 The
central tipped object with gray contrast shown in Figure 2e
comes from a NW underneath the one that was being bent.
It drifted away from the examined NW in the later bending
process, as shown in parts b and d of Figure 2. The neutral
stress zone shifted to the compressive side as indicated in
Figure 2e. The shift of the neutral stress zone can be
understood by the fact that the plastic deformation happened
on the convex of the NW first due to asymmetrical features
of the Schmidt factors under tensile and compressive strain
loads31 and then shifted toward the concave direction.

To shed light on the atomic mechanism about the elastic—
plastic and pure plastic deformation in the SiC NWs, a close
view of the deformation process is conducted. At the atomic
level, as revealed in Figure 3a, the top plastic deformed areas
are a mixture of disordered atomic lattices/planes, bent
lattices, and amorphous zones. This is similar to our previous
reported case in an ex situ experiment at a higher strained
rate.28 In fact, the morphology shown in Figure 3a occurs at
the near-end of the plastic-deformed amorphization process
rather than at the beginning. Parts b and c of Figure 3 show
an early incipient stage of the elastic—plastic transition that
is characterized by homogeneous lattice distortion, disloca-
tion nucleation, and lattice relaxation in the compressed side
of the bent SiC NW. Figure 3c is an enlarged high-resolution
electron microscopy (HREM) image taken from the framed
region of Figure 3b. The elastic/plastic anisotropy is revealed
in the incipient elastic—plastic transition period in the bent
SiC NW when an external force is applied. The periodicity
and continuity of the {111} family of lattice planes have

Figure 3. (a) The topmost regions, revealing the well-developed
plastic-deformation features. The subscript “O” represents original
lattice while “bent” means the bent lattices. (b) A low-magnification
image of the bent SiC NW from the compressive side. (c) The
enlarged area taken from the framed region of (b) to show the
incipient elastic—plastic transition features at the atomic scale. (d)
The head—tail connection of the Si—C atom pairs30 to represent
the two-dimensional projection of the Si—C atomic pairs. It shows
more clearly the characters of the (111) bent lattices and disloca-
tions/stacking faults on the (111) planes. The blue open circle
indicates the Si atoms and the orange open circle represents the
carbon atoms. The gray bars illustrate the bonds on the {111}
shuffle plane and the orange ones are those for the {111} glide
planes. See Figure 4 for more details.

Figure 4. An area at the middle stage of plastic bending of the
bent SiC NW showing the features of lattice bending, formation
of dislocations, and the process of amorphization. (a) A low
magnification image. (b) The enlarged area of the framed region
of (a). Two areas are picked up, and we use the classic head—tail
connection30 to represent the two-dimensional projection of the
Si—C atomic pairs. The symbols have identical meanings with those
of Figure 3. The white dashed line indicates the bent lattice from
region II to I, and the bent magnitude is represented by a 19°
angle between the orange and teal lines. Part c is a drawing of the red-
framed area in (b) and part d is a drawing showing the features for
the blue-framed region in (b). The green circled regions in (c) and
(d) indicate dislocated areas around the tip of the “crack-shaped”
amorphous valley. (c) reveals a dislocation on the (111) plane
and (d) contains a dislocation on the (111) plane. See text for
details.
been investigated. Neglecting the exact silicon and carbon atomic coordinates, we may assume that the white dots in the high-resolution TEM images are the projections of Si–C atomic “dumbbell” pairs, as in conventional lattice images. Figure 3d is plotted based on the red-framed region in the HREM image shown in Figure 3c. Figure 3e is a fast Fourier transformation (FFT) pattern corresponding to Figure 3c to show the lattice bending features which are reflected in the “arc” characteristic of the diffraction spot in reciprocal space. It is interesting to note that the continuity of the atoms on the trace of (11\(\overline{1}\)) plane is conserved better than that of (1\(\overline{1}\)1) planes. This indicates that the atomic slip occurs by gliding or shuffling on the (11\(\overline{1}\)) planes. The (1\(\overline{1}\)1) plane has a favorable Schmidt factor with respect to the direction of the applied external force. The incipient elastic–plastic transition anisotropy in the bent SiC NW derives from the distinguishable Schmidt factor values of the potential active slip systems of \{111\}(110) with respect to the applied external force. This phenomenon indicates that the Schmidt law is applicable at the nanoscale. The initiation of elastic–plastic transition by dislocation nucleation is consistent with a very recent nanoindentation simulation on nanocrystalline SiC thin film. However, no large strain plastic deformation could be conducted and no unusual low-temperature superplasticity was predicted in ref 24.

The HREM images recorded later in the process reveal the atomic mechanisms of the plastic deformation features with large strains. Figure 4a shows a low magnification image at a later stage of the “tearing/fracturing” process and (b) is a HREM image corresponding to the boxed area in (a). Figure 4b shows the up-central, fully developed amorphous region indicated by “A” and the two tearing apart areas that are labeled with I on the left-hand side and II on the right-hand side of the fracture tip. Selecting two regions near the amorphous zone in the HREM image of Figure 4b and conducting the classical head–tail connection of Si–C atomic pairs by tracing the white dots (projected Si–C atomic pairs), the two-dimensional atomic projections along the [1\(\overline{1}\)0] direction are shown in parts c and d of Figure 4. The crystalline lattice in areas I and II has been bent/torn as indicated by the white dashed line. The size of the bending is 19°. A dislocation lying in the (11\(\overline{1}\)) plane in the red frame area is inserted to compensate for the large angle bending. In the HREM image shown in Figure 4b, a close inspection reveals that the tip of the “fracture” is blunted by surrounding dislocations, which is consistent with theoretical predictions. Figure 4c, which is drawn to represent the red-framed region in Figure 4b, shows the dislocation forming on the (11\(\overline{1}\)) plane with a Burgers vector along [21\(\overline{1}\]) (or the projection of the [110] direction). Dislocations sited in a different set of close-packing atomic planes have also been observed. Figure 4d, which is drawn to represent the blue-framed area of Figure 4b, shows the dislocations on the (11\(\overline{1}\)) plane with Burgers vector along the [12\(\overline{1}\]) (also possible is a projection of [10\(\overline{1}\)] direction). The amorphous region propagates through dislocations, atomic lattice disordering, and relaxation.

Further study of the SiC NWs by in situ electron energy loss spectroscopy (EELS) offers additional evidence about our study on the mechanism of plastic deformation. Figure 5 shows the in situ EELS analysis results on the bent SiC NW. Figure 5a is the EELS results of the Si-L edge taken from three centered points of the bent SiC NW. Here we only show the information of Si because the structure of carbon may not be intrinsic due to the possible carbon contamination in TEM. For the reason of comparison, we illustrate the structure of Si-L edge of Si\(\text{3N}_4\),\(\text{6H-SiC, 3C-SiC}\), and Si\(\text{34}\) in the same figure. The inset in Figure 5a indicates the locations of labeled 1, 2, and 3 from where the EELS spectra of the bent SiC NW were recorded. Comparing to the sp\(^3\) bonding structures of Si\(\text{3N}_4\) and the crystalline 6H–SiC, the peak in the spectra from region A of the deformed SiC expands to a wider range with amorphous features. In contrast to the structure of the electron-irradiated SiC, we conclude that the peak at region A is the typical feature of the amorphous phase. However, the fine structures of the deformed SiC shown in region B and region C have similar structures to those of crystalline structure of 6H–SiC and

![Image](image-url)
the halo ring segments, which are typical feature of amor-phous. Figure 6c is the dark field image by selecting the (111) diffraction spot of Figure 6b which is indicated by a small red circle. The bright contrast regions in Figure 6c are the crystalline areas that contribute to the diffraction of (111). The central dark regions are the amorphous areas which do not participate in the (111) crystalline plane diffraction. Figure 6d is a high-magnification HREM image taken from the framed region of Figure 6a. Three regions were selected to conduct the FFT as shown in parts e—g of Figure 6, respectively. Parts f and g of Figure 6 show crystalline features, while Figure 6e has typical amorphous character. Some crystalline lattice features can be revealed in the left bottom area (f) of Figure 6e and some crystalline domains/islands can be eventually found in the amorphous “sea” in the enlarged HREM image of Figure 6c. On the basis of the above analysis, we suggest that the amorphous-like deformation zone of SiC contains both disordered and tiny crystalline units. The sp³ bonding features were kept in the deformed SiC regions. The structure of the necked “amorphization zone” of the deformed SiC has distinctive fine structure compared to the electron-irradiation induced amorphous SiC.

It is worthwhile to point out that the strength of the SiC NWs is the highest one so far among all of the available NWs having ever been tested. It is close to the theoretical predicted value of 5% E. But the data reported in ref 6 has reached a value that is twice that of the theoretical limit by Orowan expression estimation. Our observation may offer a reasonable interpretation about this result. The plastic deformation process could be involved in the bending case of SiC NWs in ref 6. Derived from present observation, we suggest that metal-like dislocation interactions, lattice disordering, and amorphization occurred simultaneously in the lateral bending process reported in ref 6. The conservation of sp³ bonding in the amorphous phase contributes to the continuous increase of the bending strength of SiC NWs. A three-step deformation was involved in this process in which a strain-induced phase transition from crystalline to amorphous was observed in this study.

The results clearly revealed the distinct mechanical properties of individual SiC NWs with a bending-induced large strain plasticity at temperatures close to room temperature, which has never been observed in bulk ceramic materials. The large strain plasticity may correspond to superstrength. The direct dynamic atomic level elastic-plastic and B—D transition images and mechanisms for a single SiC NW are different from those of the bulk materials and amplify the strong scale effect. The process is distinctive from the “one step transition” mechanism in the MD simulation from the crystalline to the amorphous phase. It is also different from another type of thermal/stress-activated elastic instability and B—D transition in which the mobility of the existing dislocations is the main concern. The scale effect contributes to the new triple-step deformation mechanisms of the ceramic NWs in addition to the well-accepted temperature and strain rate factors. The unusual phenomena found for the SiC NWs are fundamentally important for understanding the strain-induced band structure variation and the corresponding changes in transportation.

Figure 6. The amorphous structure at the necked valley of the plastically deformed SiC NW. (a) A bright field low-magnification HREM image to show the features of the plastically deformed SiC NW. (b) A selected area electron diffraction pattern taken from both of the amorphous and crystalline regions. (c) A dark field image obtained by selecting the (111) diffraction spot of (b). The bright contrast regions in (c) are the crystalline areas which contribute to the diffraction of (111). The central dark regions are the plastically deformed amorphous areas which do not participate in the (111) crystalline plane diffraction. (d) A high-magnification HREM image taken from the framed region of (a). The three selected regions are marked by red, green, and blue frames and conducted fast Fourier transformation (FFT) as shown in (e), (f), and (g), respectively.

Si₃N₄. The characters of the EELS peaks at zone C of the deformed SiC at the peak position P shift to a high-energy position for about 3–5 eV. To confirm the amorphous features of the deformed SiC, we studied the plasma peak of the bent SiC as shown in Figure 5b. The plasma peak of the bent SiC NW shifts to the higher energy compared to the undeformed one, and this is a character of the disordered structure. In addition to the EELS analysis, to unambiguously demonstrate the amorphous structure of the plastically deformed SiC NW, we studied the plastically deformed necking-valley region of the bent SiC NW by selected area electron diffraction and dark-field imaging as well as high-magnification HREM imaging. Figure 6a is a low-magnification bright field HREM image to show the features of the plastically deformed SiC NW. In the selected area diffraction pattern as shown in Figure 6b, the small red arrows indicate the halo ring segments, which are typical feature of amor-phous.

property of semiconductor NWs. Our result may also provide useful information for further studying of nanoscale elastic—plastic and brittle—ductile transformation of ceramic materials with superplasticity.

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Supporting Information Available: Experimental details providing general information, electron beam temperature increase, and calculation of elastic strain. This material is available free of charge via the Internet at http://pubs.acs.org.

References

26. Supporting Information. 